



Soft and Hard X-Ray Microscopy

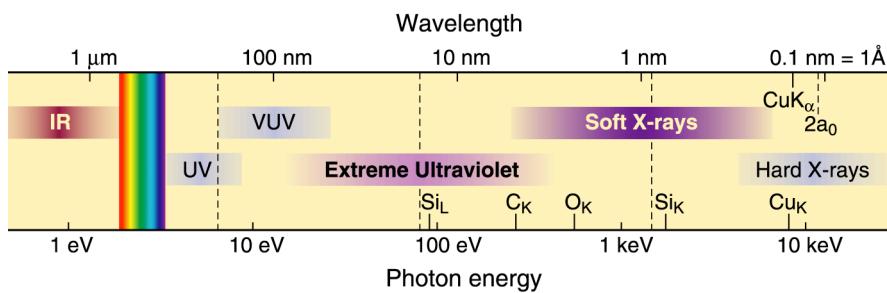
David Attwood
University of California, Berkeley

Cheiron School
September 2011
SPring-8

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The short wavelength region of the electromagnetic spectrum



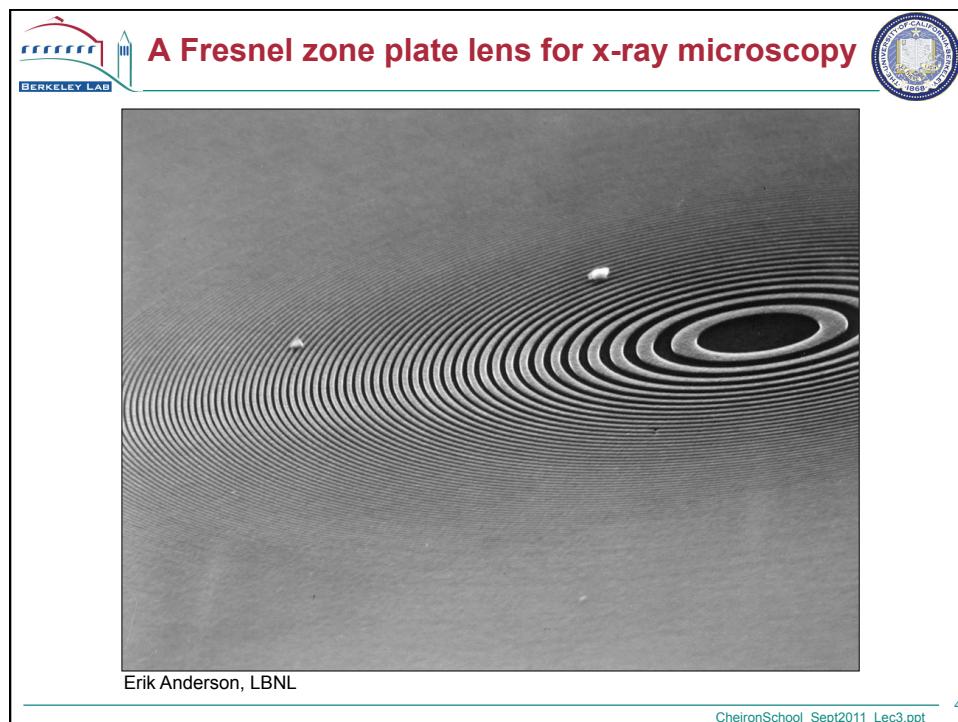
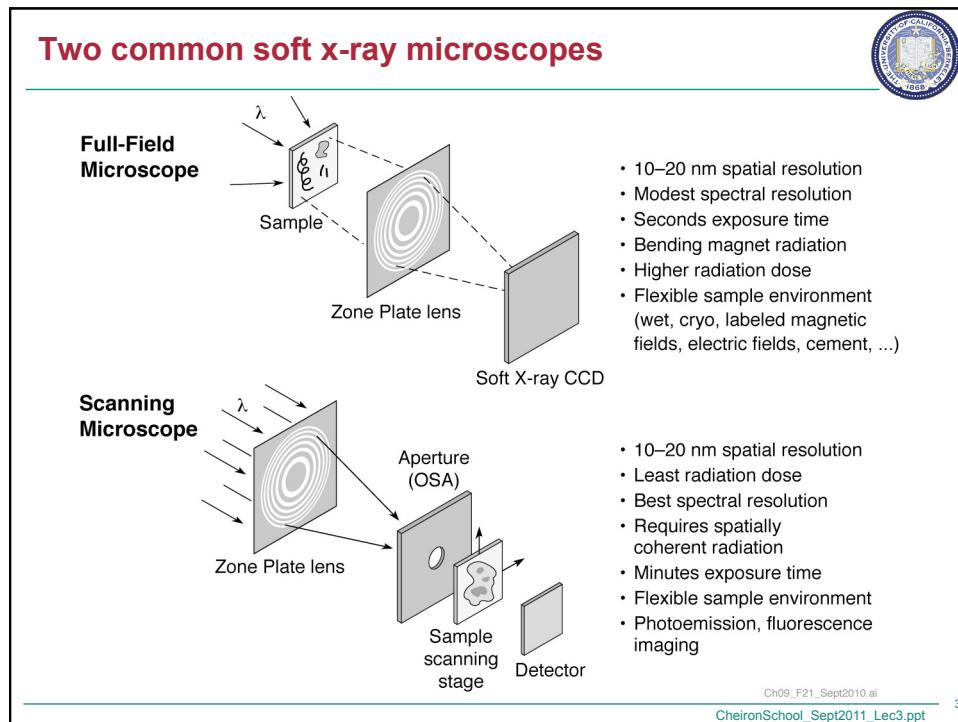
- See smaller features
- Write smaller patterns
- Elemental and chemical sensitivity

$$\hbar\omega \cdot \lambda = hc = 1239.842 \text{ eV nm}$$

$$n = 1 - \delta + i\beta \quad \delta, \beta \ll 1$$

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Nature
LETTERS

Vol 435|30 June 2005|doi:10.1038/nature-3719

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Soft X-ray microscopy at a spatial resolution better than 15 nm

Weilun Chao^{1,2}, Bruce D. Harteneck¹, J. Alexander Liddle¹, Erik H. Anderson¹ & David T. Attwood^{1,2}

Abstract Tools that have spatial resolution in the nanometer scale are indispensable for the life and physical sciences. It is desirable that these tools also permit elemental and chemical identification on a scale of 10 nm or less, with large penetration depths. A variety of techniques^{1–4} in X-ray imaging are currently being developed that may eventually achieve such performance. We report the achievement of sub-15-nm spatial resolution with a soft X-ray microscope—and a clear path to below 10 nm—using an overlay technique. This approach uses a zone plate to project a narrow spectral range from a photon energy of 250 eV (~5 nm wavelength) to 1.8 keV (~0.7 nm), so that primary K and L atomic resonance edges are sequentially probed. The sample is sequentially probed. This X-ray microscopy technique is therefore suitable for a wide range of studies: biological imaging in the water window^{5,6}; studies of buried electronic devices in the silicon window^{7,8}; nanomaterials with both elemental and spin-orbit sensitivity^{9–12}; studies that require viewing through thin windows, coatings or substrates (such as buried electronic devices in a silicon “flip chip”¹³); three-dimensional imaging of cryo-electronically fixed cells^{14,15}.

The soft X-ray microscope (SXM) at the Advanced Light Source (ALS) in Berkeley¹⁶ is schematically shown in Fig. 1. The microscope type is similar to that pioneered by the Gottingen/BESSY group (ref. 18, and references therein). A “multi-exposure” (ME) project¹⁷ acquires a full-field image to an X-ray-sensitive CCD (charge-coupled device) typically in one or a few seconds, often with several hundred images per day. The field of view is typically 10 μm, corresponding to a magnification of $\times 2,500$. The zone plate (ZP) used in the SXM, which serves two purposes in that it provides partially coherent hollow-cone illumination¹⁸, and, in combination with a pinhole, serves as the monochromator. Monochromatic radiation of $\lambda/\Delta\lambda = 500$ is used. Both zone plates are fabricated in-house, using electron beam lithography.

The spatial resolution of a zone plate based microscope is equal to $k_1 \lambda N_{A_{ZP}}$, where λ is the wavelength, $N_{A_{ZP}}$ is the numerical aperture of the zone plate, and k_1 is the diffraction limit of the instrument, which ranges from 0.3 to 0.61. For a zone plate lens used at high magnification, $N_{A_{ZP}} = \lambda/\Delta r_{ZP}$, where Δr_{ZP} is the outermost zone width of the zone plate. For the zone plate used here, the coherent illumination^{19,20} used here, $\lambda_c = 0.4$ and thus the theoretical resolution is $0.8\Delta r_{ZP}$, as calculated using the SPLAT computer program²¹. In previous results with a $\Delta r_{ZP} = 23$ nm zone plate, we reported²² an unambiguous spatial resolution of 20 nm. This work shows that the resolution can be improved to 15 nm with a $\Delta r_{ZP} = 15$ nm zone plate.

This technique overcomes nanofabrication limits due to electron beam broadening in high feature density patterning. Beam broadening results from electron scattering within the recording medium (resist), leading to a loss of image contrast and thus resolution for

Figure 1 | A diagram of the soft X-ray microscope XM1. The microscope uses a micro zone plate to project a full field image onto a CCD camera that is sensitive to partially coherent hollow-cone illumination. The illumination of the sample is provided by a condenser zone plate. A central stop and a pinhole provide monochromatization.

Figure 2 | A schematic diagram of the soft X-ray microscope XM1. The diagram shows the optical path from the source (X-ray tube) through the ALS bending magnet, the pinhole, the condenser zone plate, the sample, the micro zone plate, and the soft x-ray sensitive CCD camera.

Figure 3 | A diagram of the soft X-ray microscope XM1 showing the zone plate fabrication process. The diagram illustrates the fabrication of zone plates using electron beam lithography and lift-off processes.

Figure 4 | Soft X-ray images of a 15.1 nm half-period test object, as formed with zone plates having outer zone widths of 25 nm and 15 nm. The figure shows two side-by-side images of a Cr/Si test pattern (Cr L₃ @ 574 eV) with a resolution of 2000 X 2000, 10⁴ ph/pixel. The left image is taken with a 25 nm outer zone width, and the right image is taken with a 15 nm outer zone width.

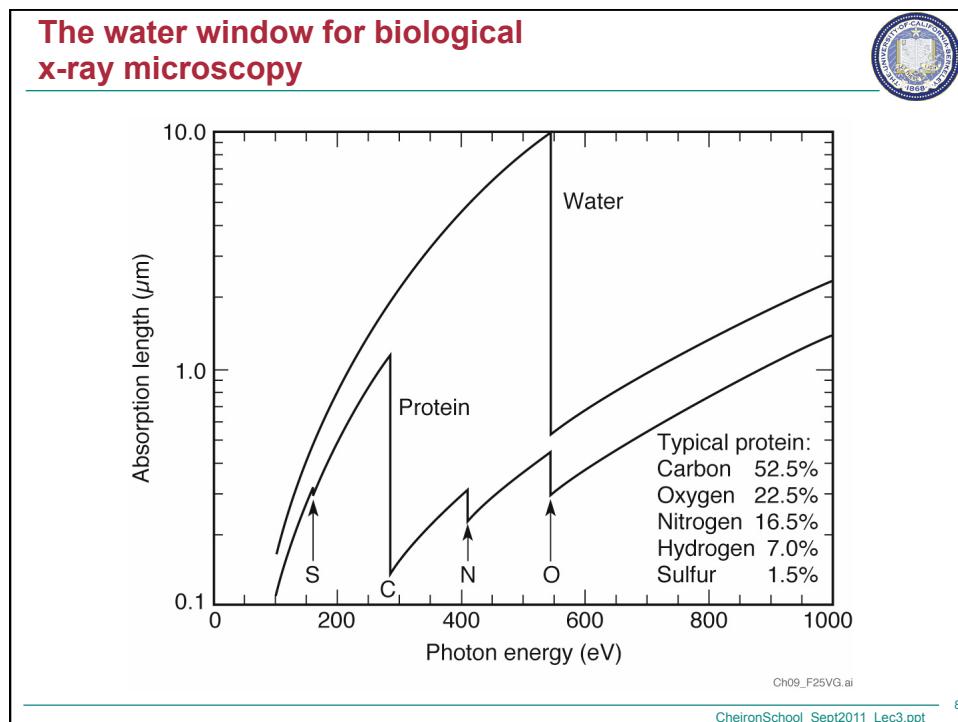
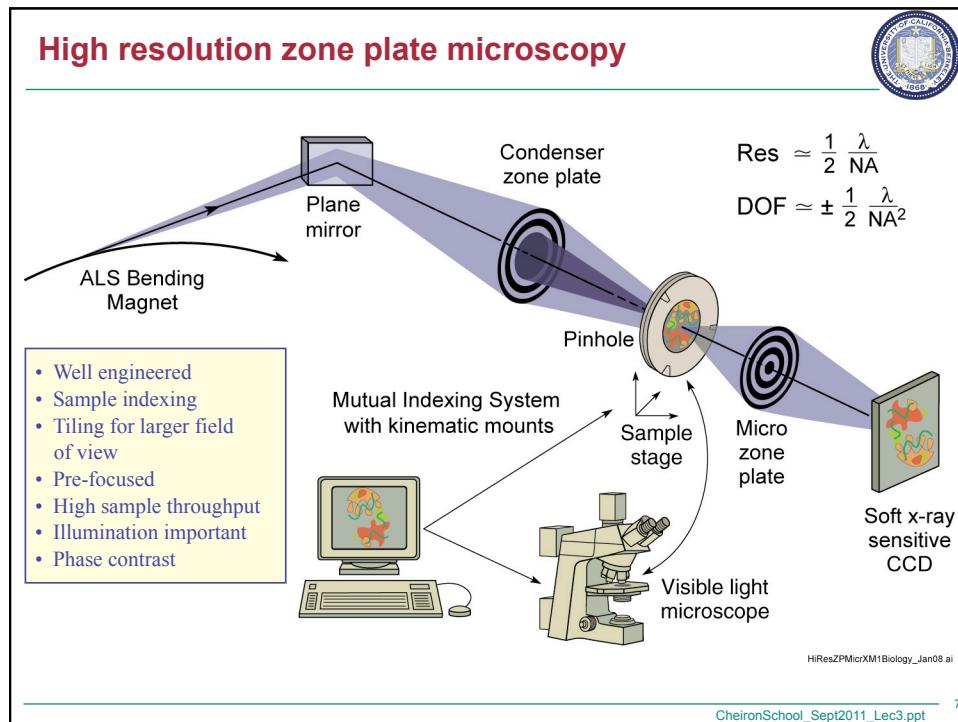
Cr/Si test pattern (Cr L₃ @ 574 eV)
(2000 X 2000, 10⁴ ph/pixel) [I_Lec3.ppt](#)

Novel zone plates for specific functionality

New x-ray lenses:
Improving contrast and resolution for x-ray microscopy

Courtesy of Anne Sakdinawat, UC Berkeley

[CheironSchool_Sept2011_Lec3.ppt](#)



Fast freeze cryo fixation strongly mitigates radiation dose effects

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Cold Helium

From condenser zone plate

Pinhole

Sample

μ zp

To CCD

Helium passes through LN, is cooled, and directed onto sample windows

Fast Freeze

Temperature (Celsius)

Time (milliseconds)

$\Delta T = -50^\circ\text{C}$

$\Delta t = 16 \text{ ms}$

W. Meyer-Ilse, G. Denbeaux, L. Johnson, A. Pearson (CXRO-LBNL)

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Organelle details imaged with cryogenic preservation and high spatial resolution

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Cryo x-ray microscopy of 3T3 fibroblast cells

ER

Filopodia

Nucleus

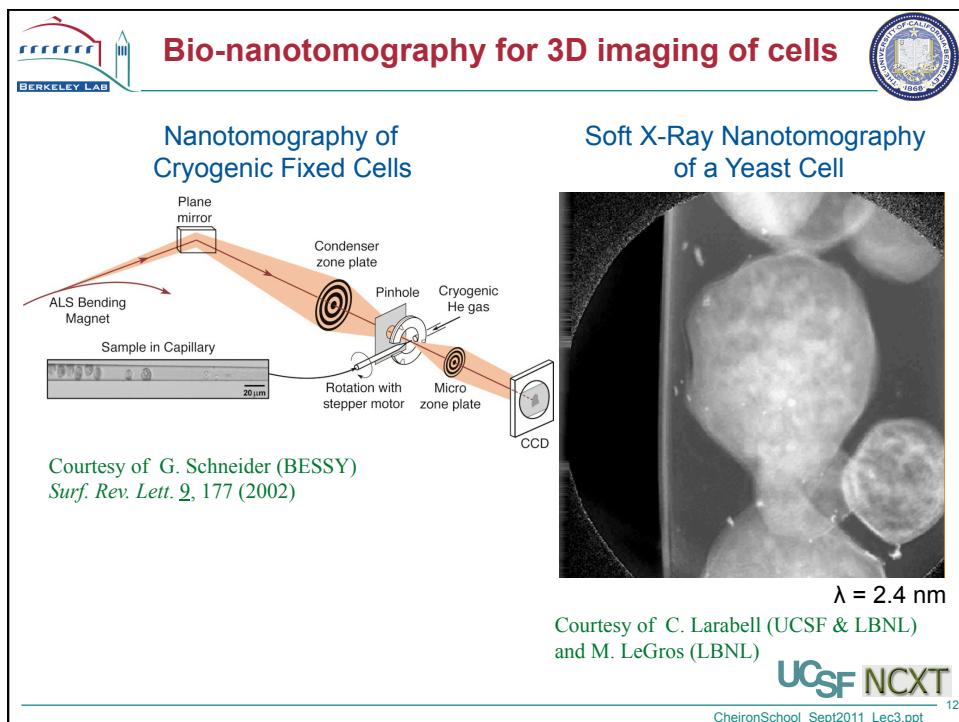
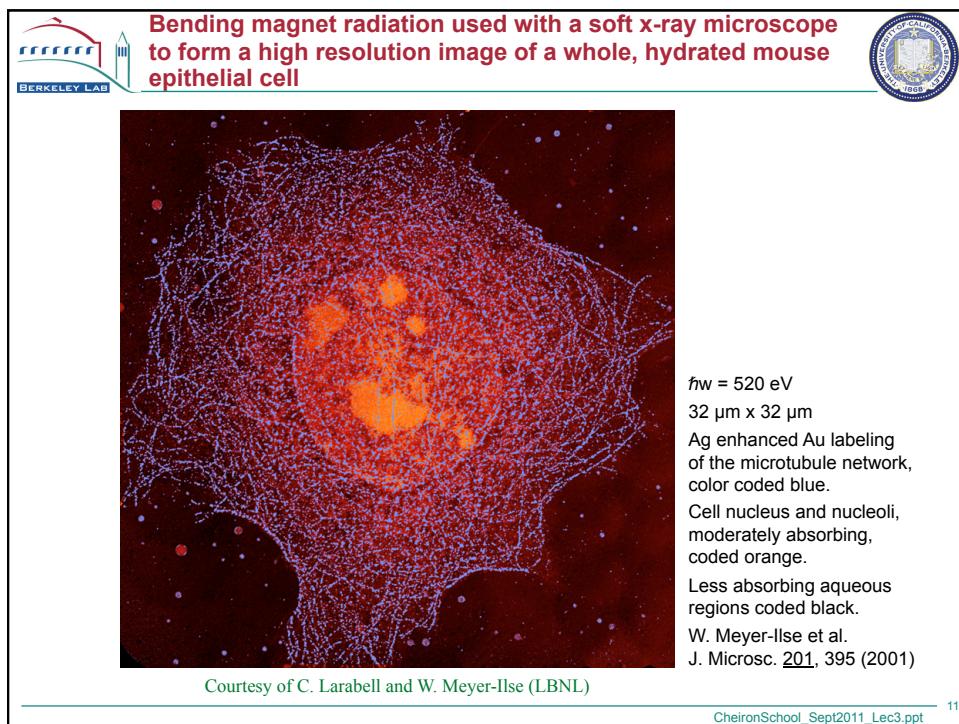
Nucleoli

Cell border

5 μm

C. Larabell, D. Yager, D. Hamamoto, M. Bissell, T. Shin (LBNL Life Sciences Division)
W. Meyer-Ilse, G. Denbeaux, L. Johnson, A. Pearson (CXRO-LBNL)

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Bio-nanotomography for 3D imaging of cells

Nanotomography of Cryogenic Fixed Cells

ALS Bending Magnet
Sample in Capillary
Plane mirror
Condenser zone plate
Pinhole
Cryogenic He gas
Micro zone plate
Rotation with stepper motor
CCD

$\lambda = 2.4 \text{ nm (517 eV)}$
 $\Delta r = 35 \text{ nm}$
 $N = 320$
 $\text{NA} = 0.034$
 $D = 45 \mu\text{m}$
 $f = 650 \mu\text{m}$
 $\sigma = 0.64$
Resolution = 60 nm

Soft X-Ray Nanotomography of a Yeast Cell

$\lambda = 2.4 \text{ nm}$
Courtesy of C. Larabell (UCSF & LBNL) and M. LeGros (LBNL)

UCSF NCXT

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Nanoscale 3-D biotomography

Mother daughter yeast cells just before separation

2-D slice from 3-D Tomogram. Images every 2° , 180° data set, several minutes.
 $\Delta r = 45 \text{ nm}$

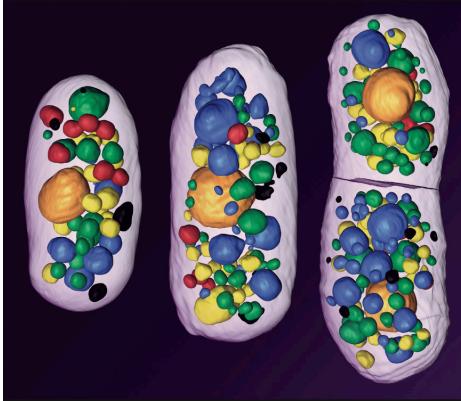
Color coding identifies subcellular components by their x-ray absorption coefficients

Courtesy of Carolyn Larabell, UCSF/LBNL.

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 **Applications of soft x-ray microscopy** 

Biotomography at 60 nm resolution



- Cryofixation
- 2° angular intervals
- Depth of focus limits resolution
- New XM-2 dedicated to biological applications, will become major facility worldwide to draw biologists to this evolving capability

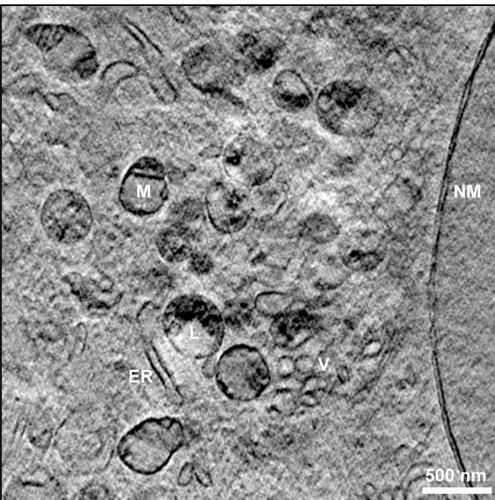
Courtesy of C. Larabell (UCSF & LBNL)

UCSF NCXT

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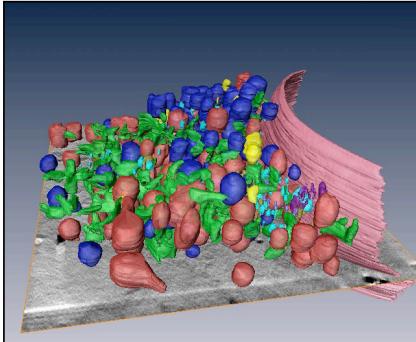
High resolution (30 nm), 3D image of a mouse cell by soft x-ray tomography 

2D slice from 3D data set



Details: 517 eV (2.4 nm)
 $\Delta r = 25 \text{ nm}$, 1° intervals, $\pm 60^\circ$.
Note 29 nm nuclear membrane.

3D rendering



Courtesy of Gerd Schneider, BESSYII and James McNally, NIH.

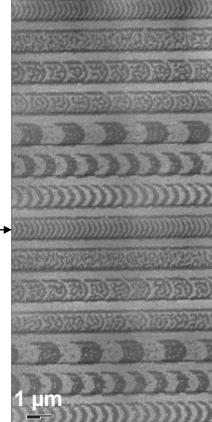
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Magnetic x-ray microscopy using x-ray magnetic circular dichroism (XMCD)



Magnetic X-Ray Microscopy

- High spatial resolution in transmission
- Bulk sensitive (thin films)
- Complements surface sensitive PEEM
- Good elemental sensitivity
- Good spin-orbit sensitivity
- Allows applied magnetic field
- Insensitive to capping layers
- In-plane and out-of-plane measurements



100 nm lines & spaces

1 μm

Courtesy of P. Fischer, (MPI, Stuttgart) and G. Denbeaux (CXRO/LBNL)

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Magnetic domains imaged at different photon energies

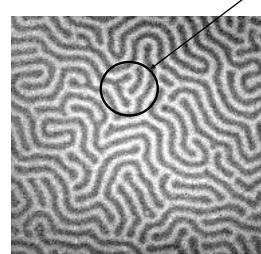


FeGd Multilayer



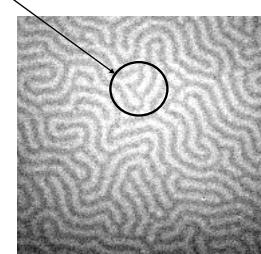
1 μm

$\hbar\omega = 704$ eV
below Fe L-edges



$\hbar\omega = 707.5$ eV
Fe L₃-edge

Contrast reversal



$\hbar\omega = 720.5$ eV
Fe L₂-edge

P. Fischer, T. Eimuller, M. Koehler (U. Wuerzburg)
S. Tsunashima (U. Nagoya) and N. Tagaki (Sanyo)
G. Denbeaux, L. Johnson, A. Pearson (CXRO-LBNL)

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Magnetic recording of nanomagnetic patterns to 15 nm spatial resolution

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CoCrPt alloy
Co L₃-edge at 778 eV
(1.59 nm)

200 nm

Courtesy of Peter Fischer (LBNL)

P. Fischer et al., *Mat. Today* 9, 26 (2006).

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Time resolved studies of vortex dynamics in patterned permalloy thin films

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Pump and Probe setup requires:

- Pump: Current pulse to “pump” sample
- Probe: X-ray pulses (70ps) from ALS 2 Bunch mode
- Perfect repeatability of dynamics

Sample:

50 nm thick 2 μ m x 4 μ m permalloy (Ni₈₀Fe₂₀)
100nm thick gold waveguide (Δt along waveguide generates field to pump sample)

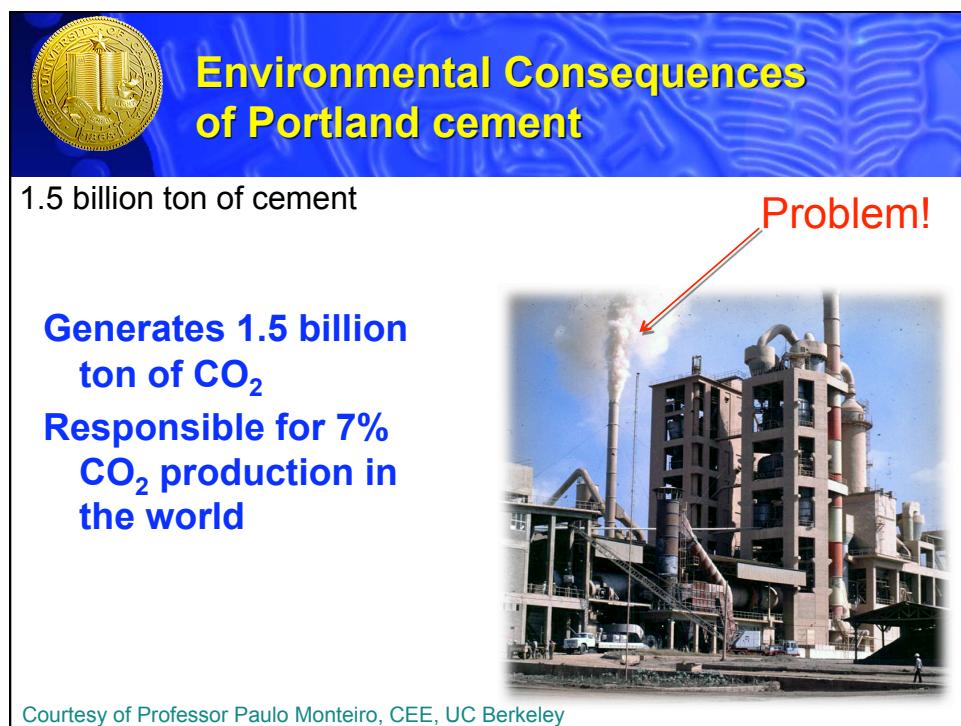
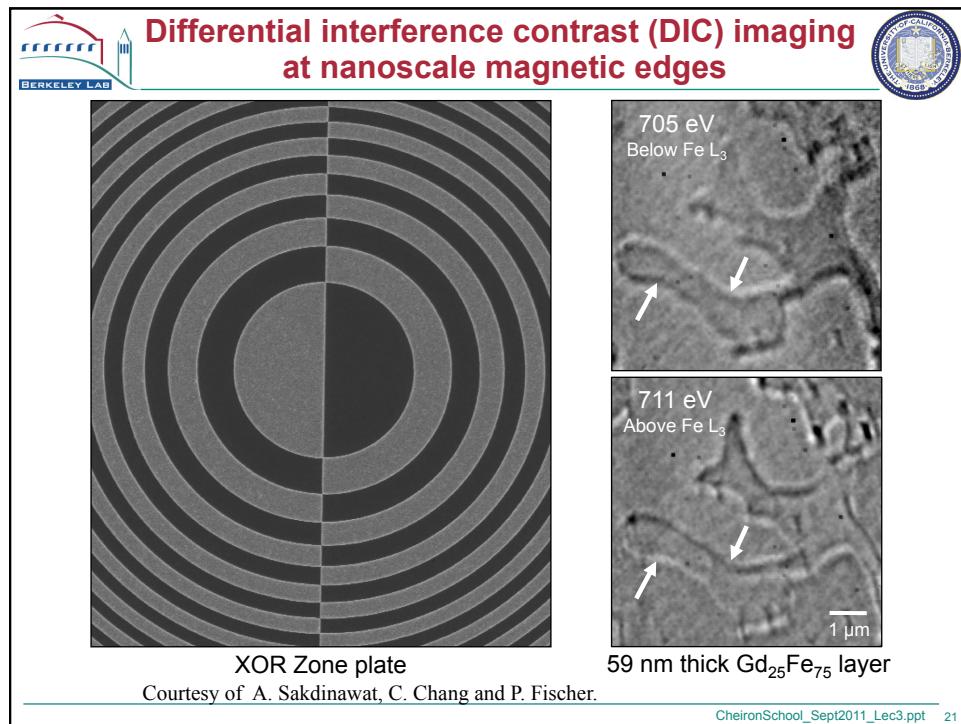
a)
Before Pump (t=0)

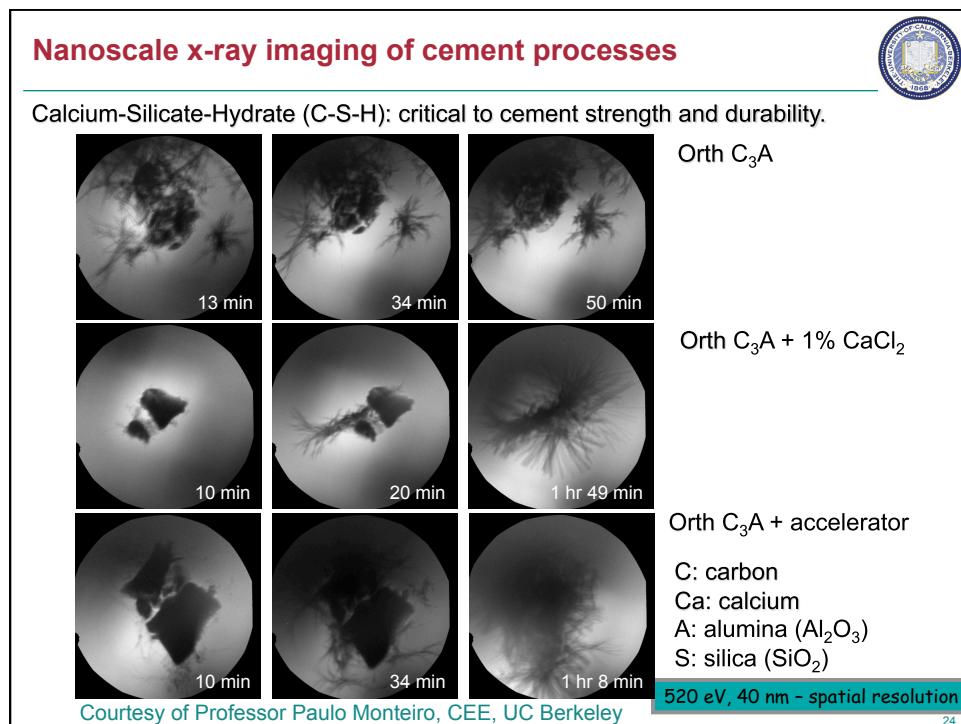
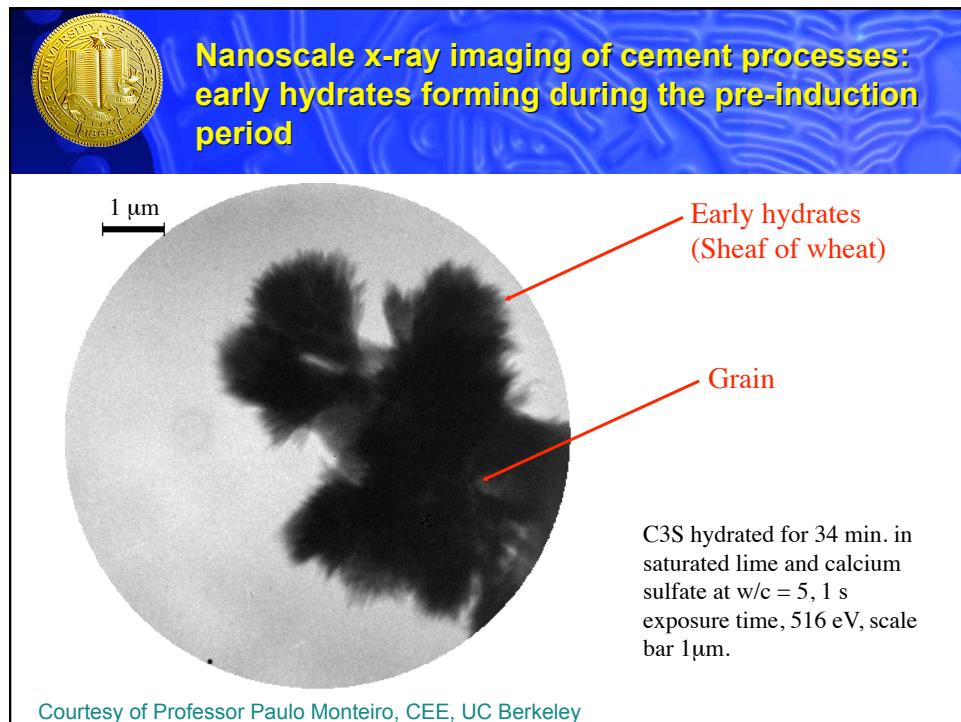
b)
t=+1 ns

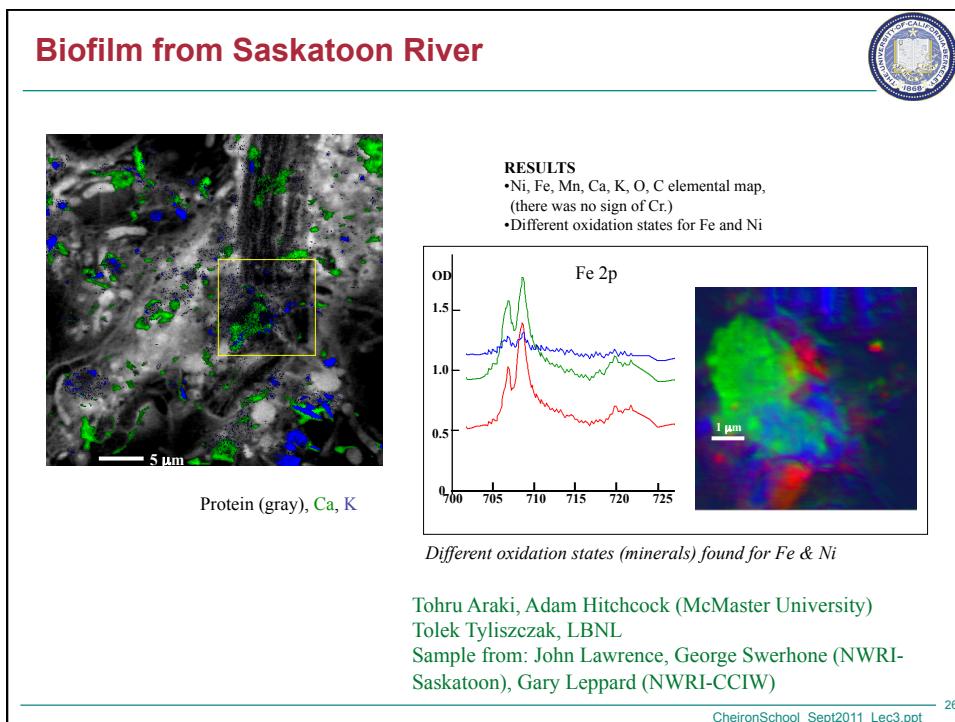
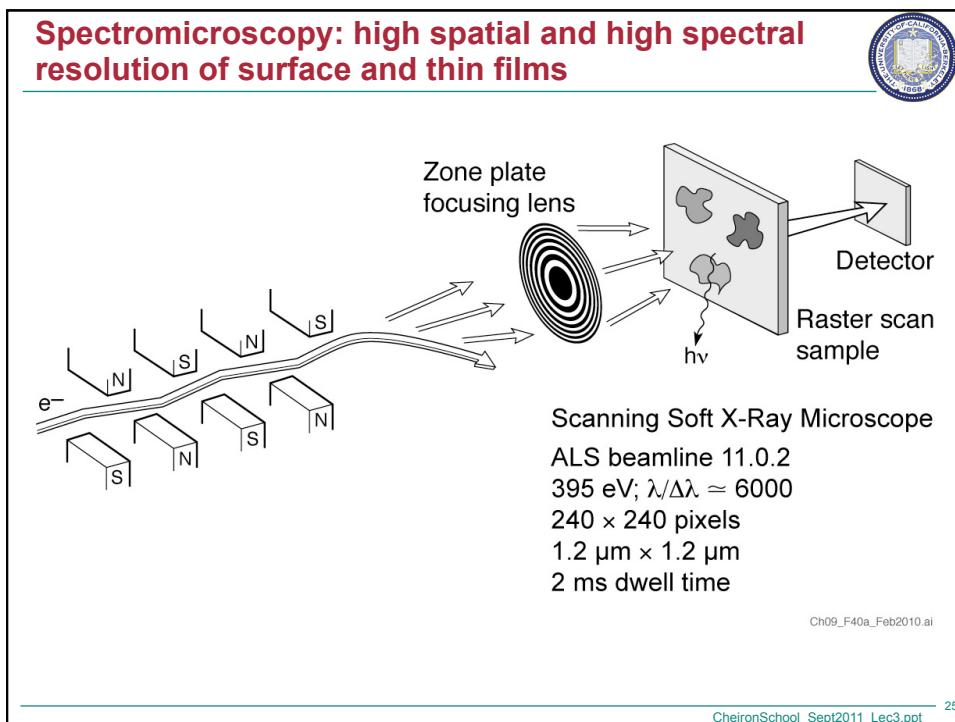
c)
t=+1.6 ns

B.L. Mesler, P. Fischer, W. Chao, E. H. Anderson, D.H. Kim *J. Vac. Sci. Technol. B* 25, 2598 (2007).

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Patterned polymer photoresists

BERKELEY LAB

ALS-MES 11.0.2

M.K. Gilles, R. Planques, S.R. Leone
LBNL
Samples from B. Hinsberg, F. Huele
IBM Almaden

Exposure to UV light results in loss of carbonyl peak

Map chemical spectra taken of pure samples onto a sample containing both components

Courtesy of Mary Gilles, LBNL

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Hard x-ray zone plate microscopy

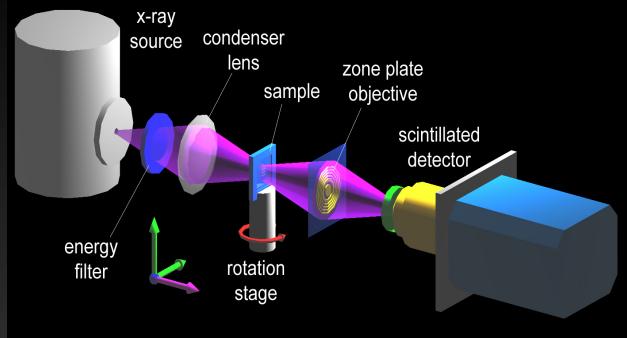
University of California Berkeley Seal

- Shorter wavelengths, potentially better spatial resolution and greater depth-of-field.
- Less absorption (β); phase shift (δ) dominates, higher efficiency.
- Thicker structures required (e.g., zones), higher aspect ratios pose nanofabrication challenges.
- Contrast of nanoscale samples minimal; will require good statistics, uniform background, dose mitigation.

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nanoXCT: Schematic and Challenges



Challenges for achieving nm scale resolution:

- High resolution objective lens: limiting the ultimate resolution
- High numerical aperture condenser lens:
- Detector: high efficiency for lab. source and high speed for synchrotron sources
- Precision mechanical system

Courtesy of Wenbing Yun and Michael Feser, Xradia

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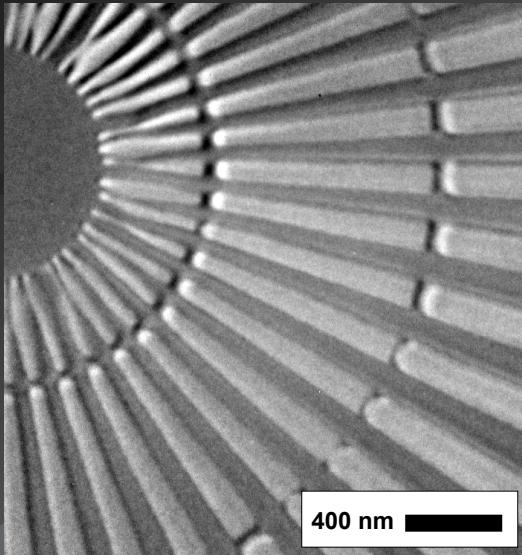
Xradia nanoXCT: Sub-25 nm Hard X-ray Image

Xradia Resolution Pattern

- 50 nm bar width
- 150 nm thick Au
- 8keV x-ray energy
- 3rd diffraction order

F. Duewer, M. Tang,
G. C. Yin, W. Yun,
M. Feser, et al.

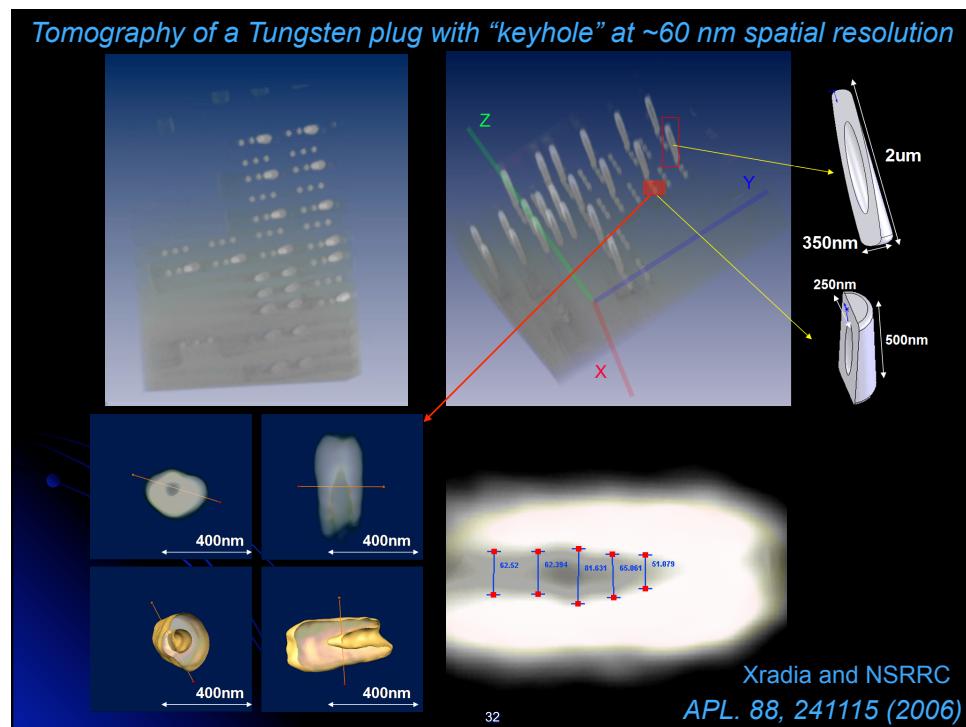
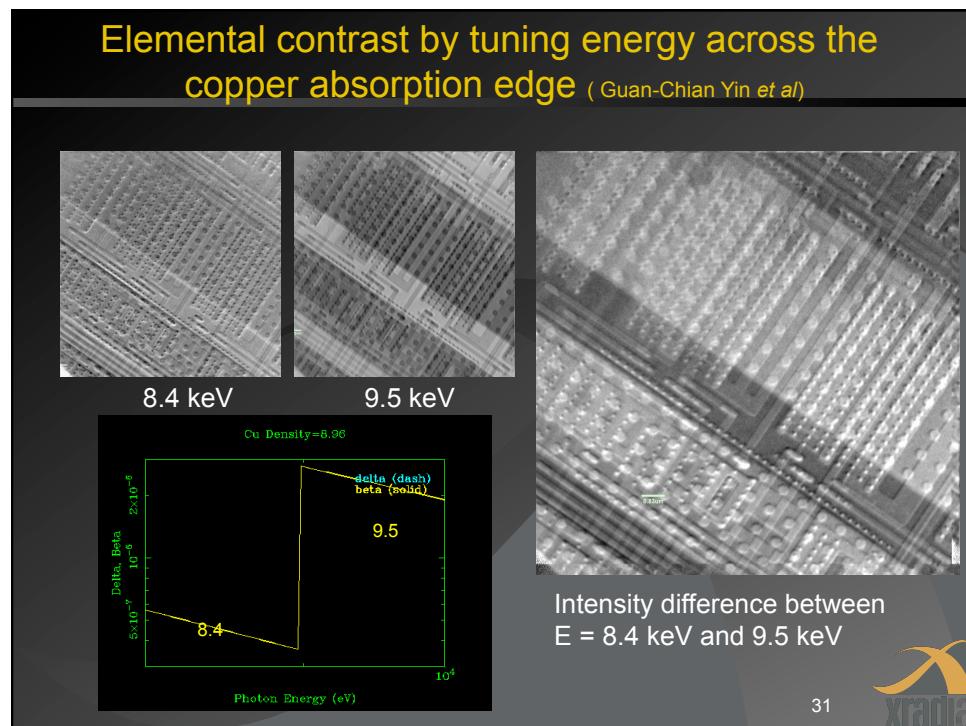
Xradia nano-XCT
8-50S installed at
NSRRC, Taiwan

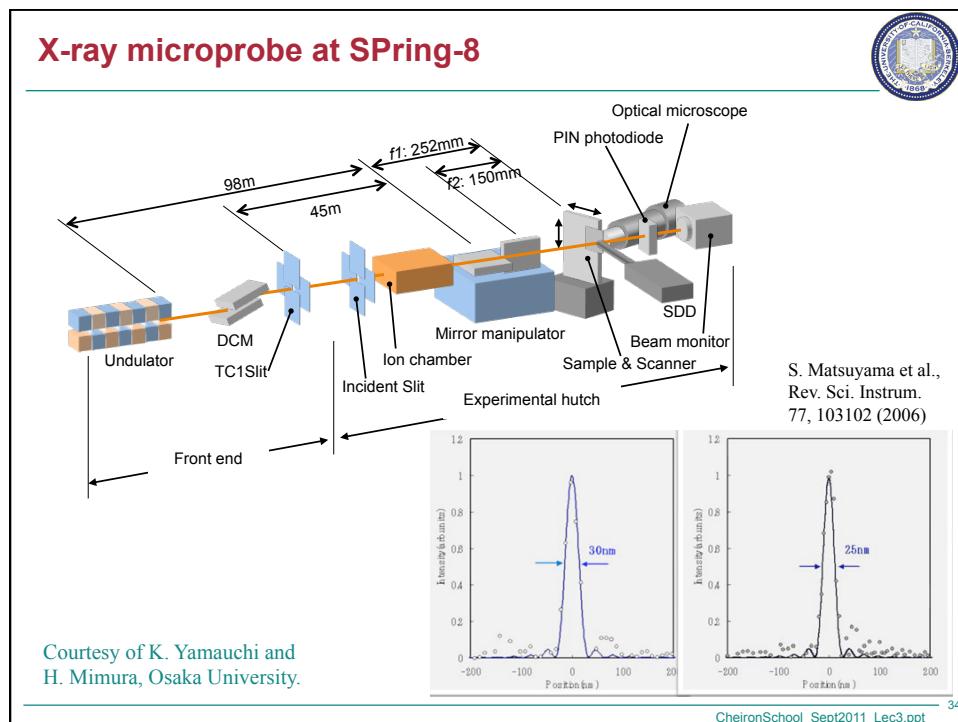
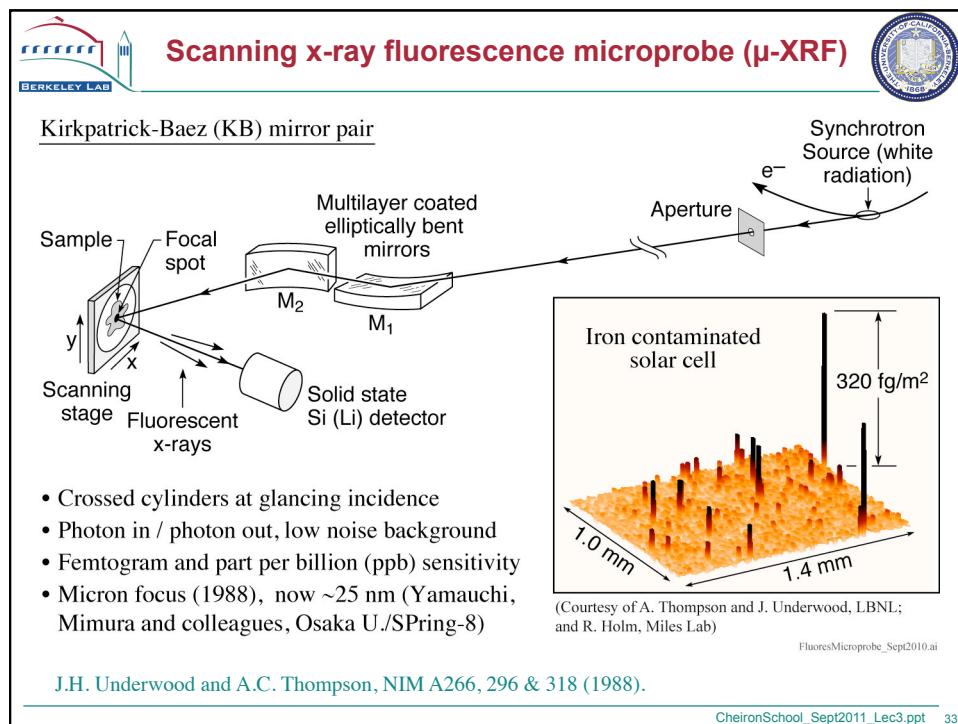


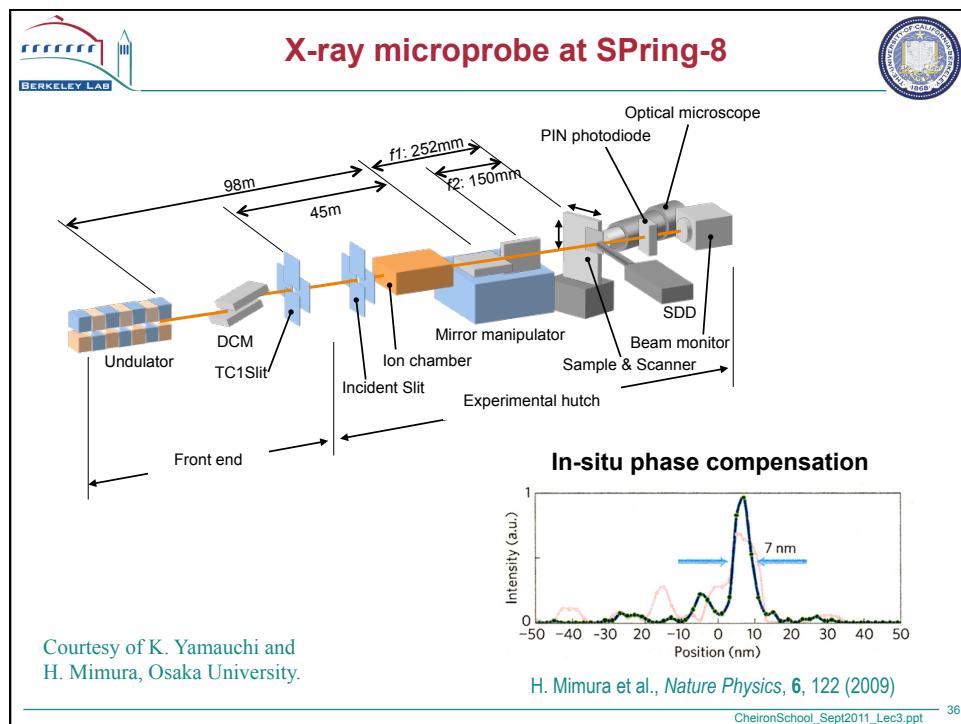
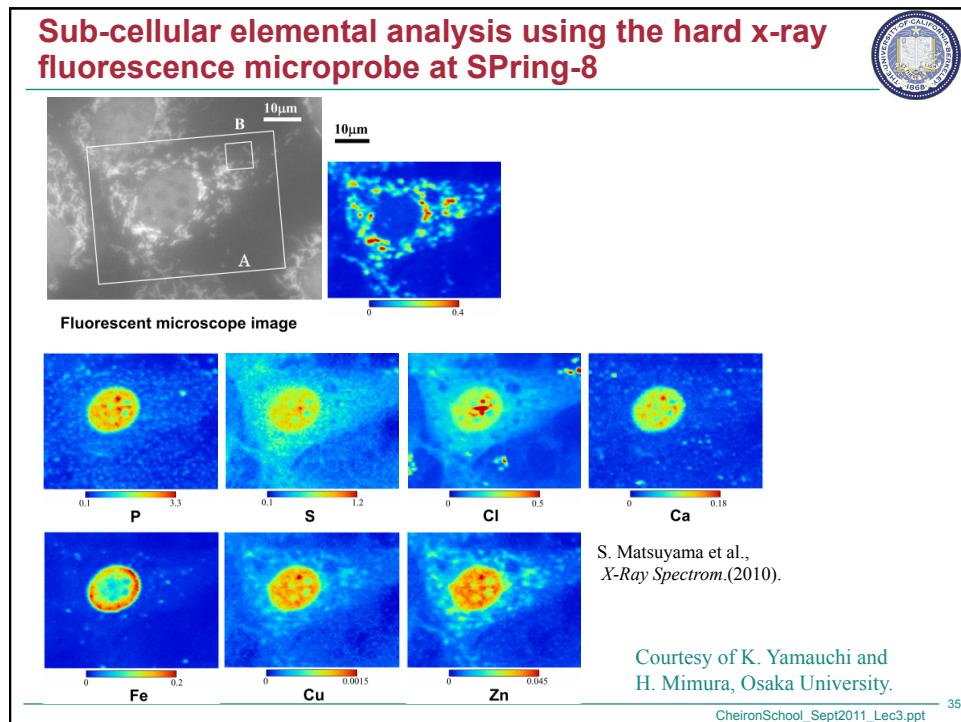
400 nm

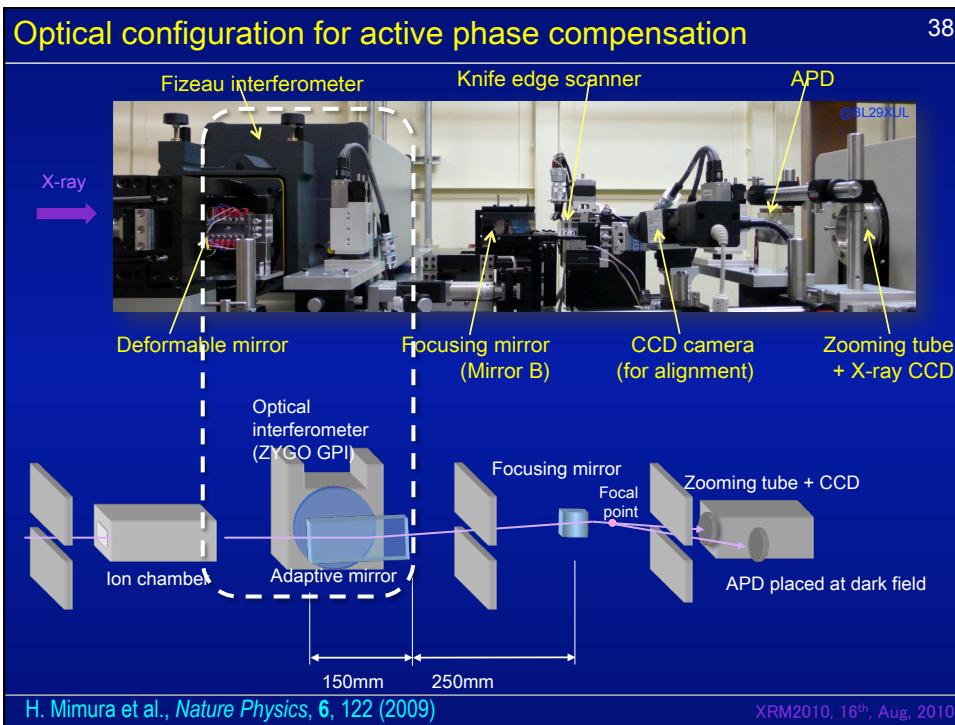
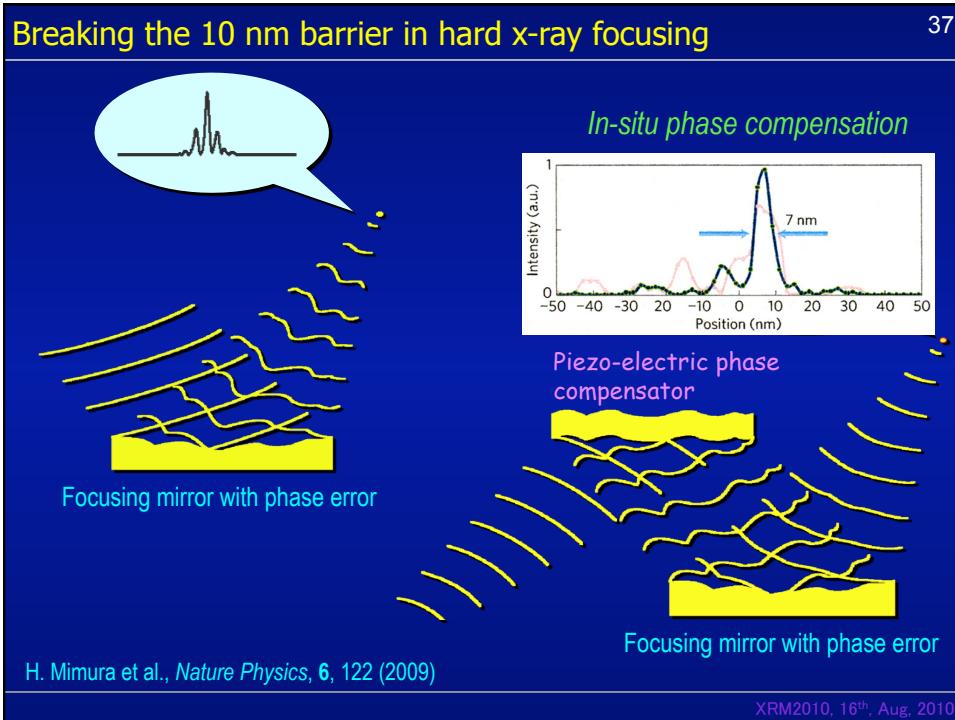
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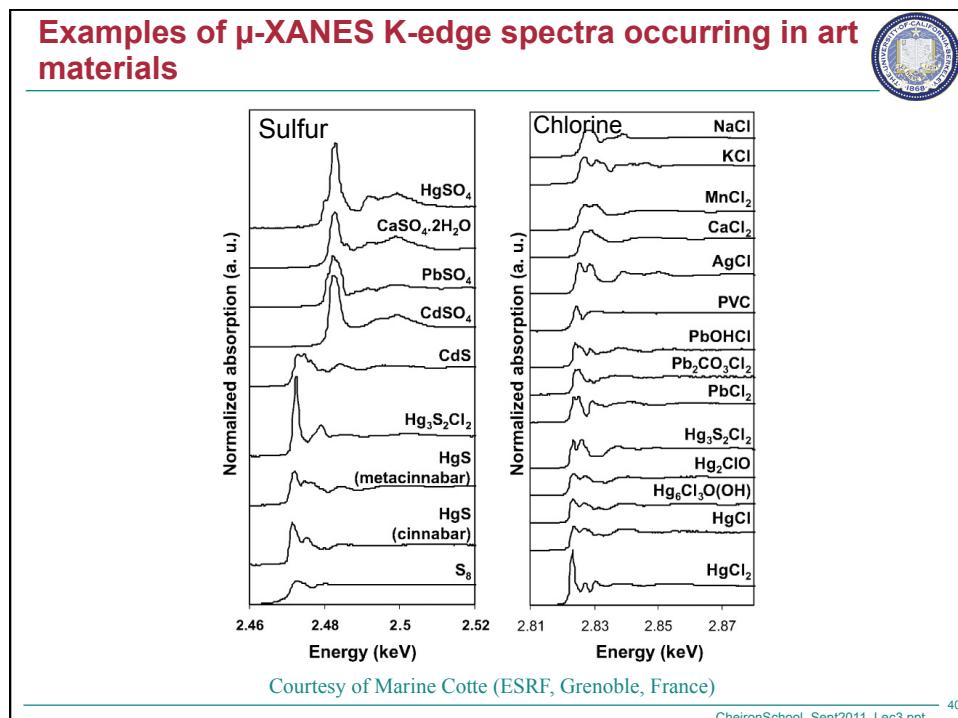
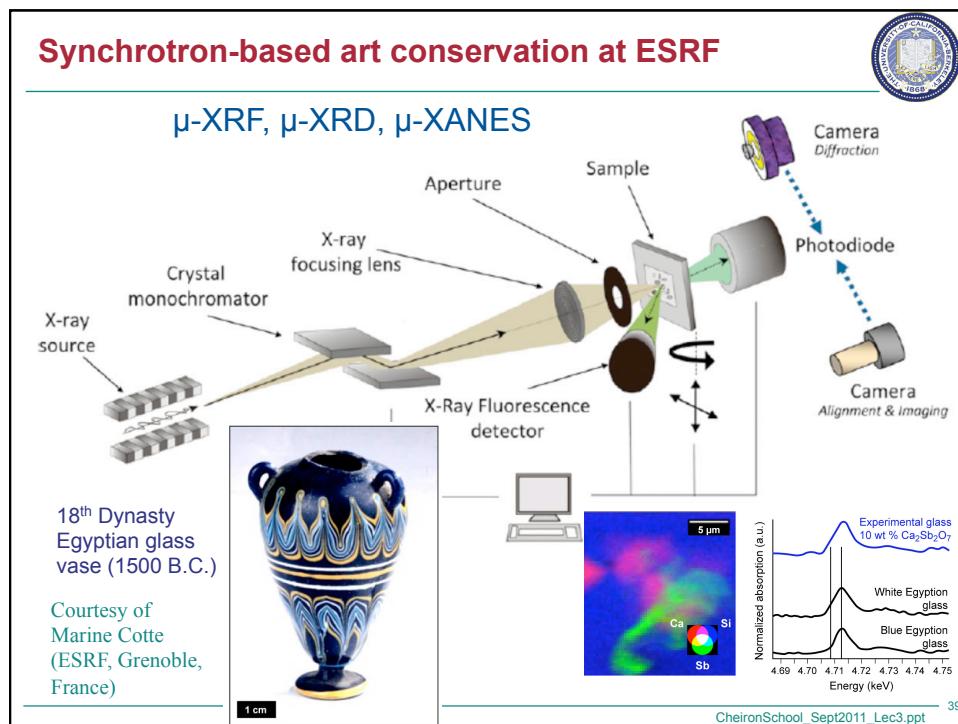


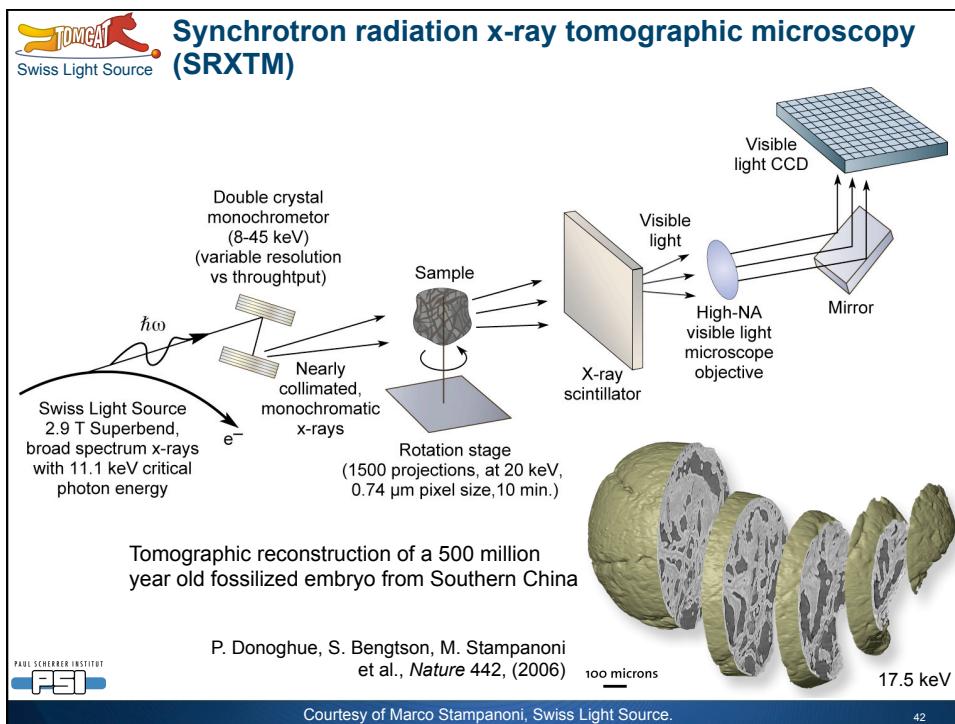
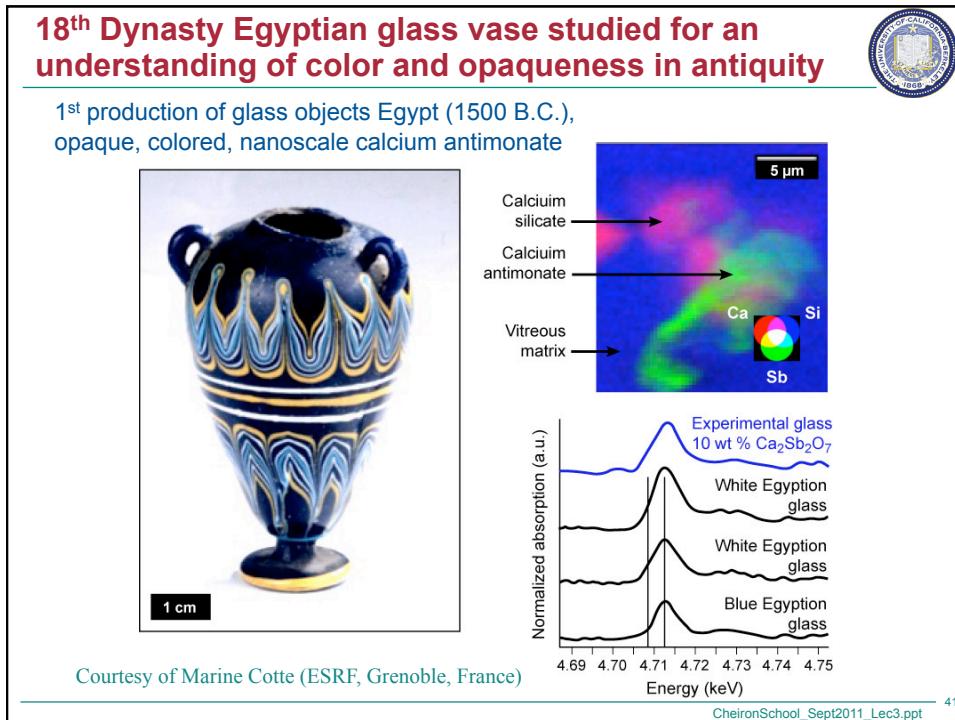


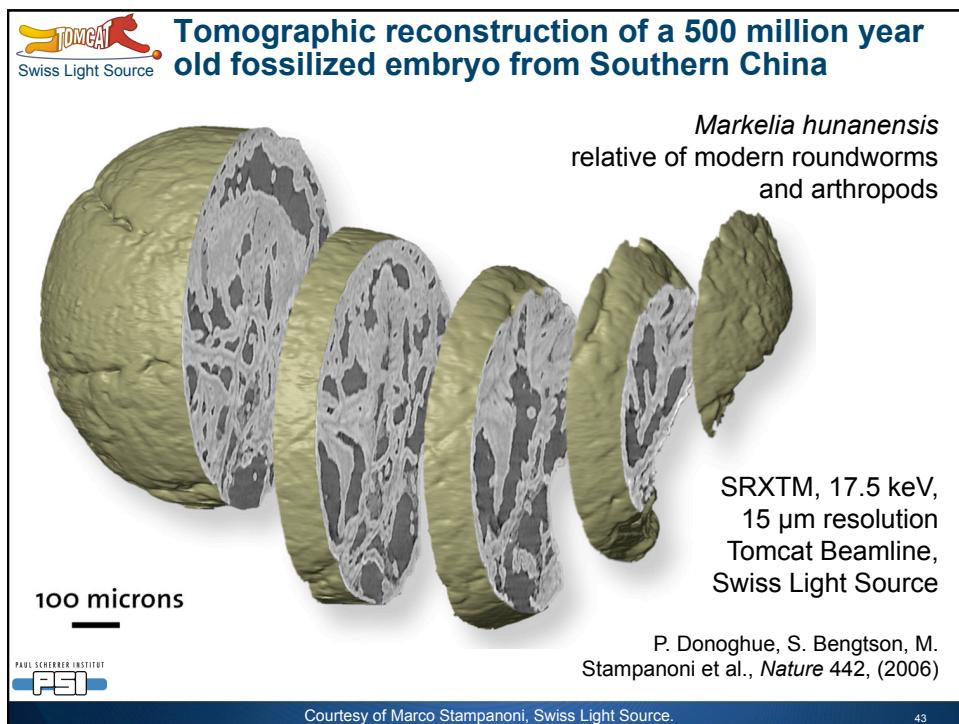


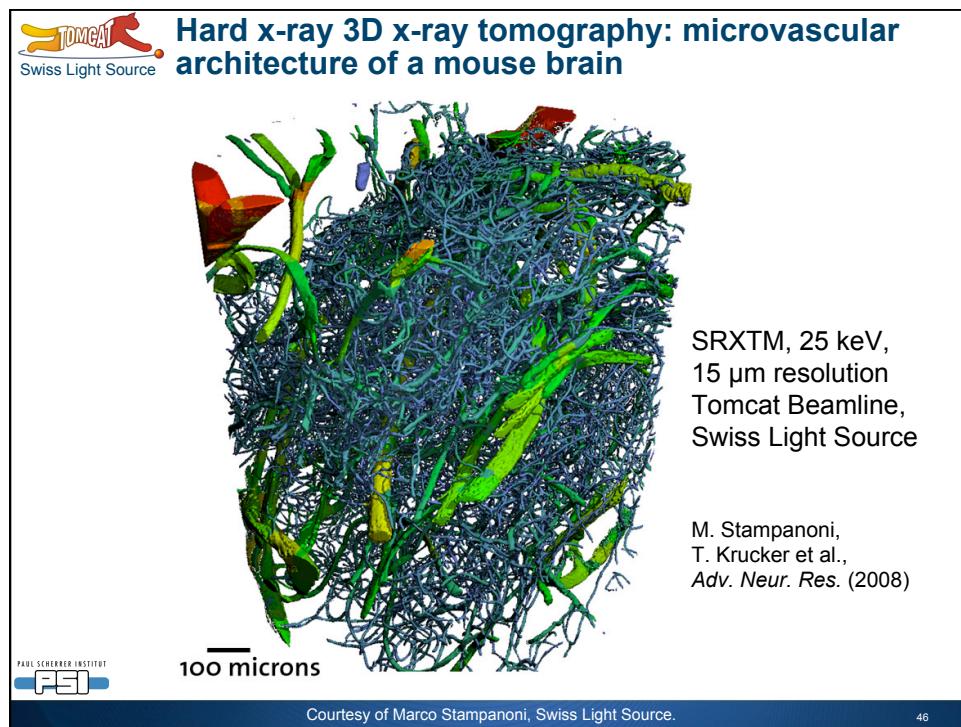
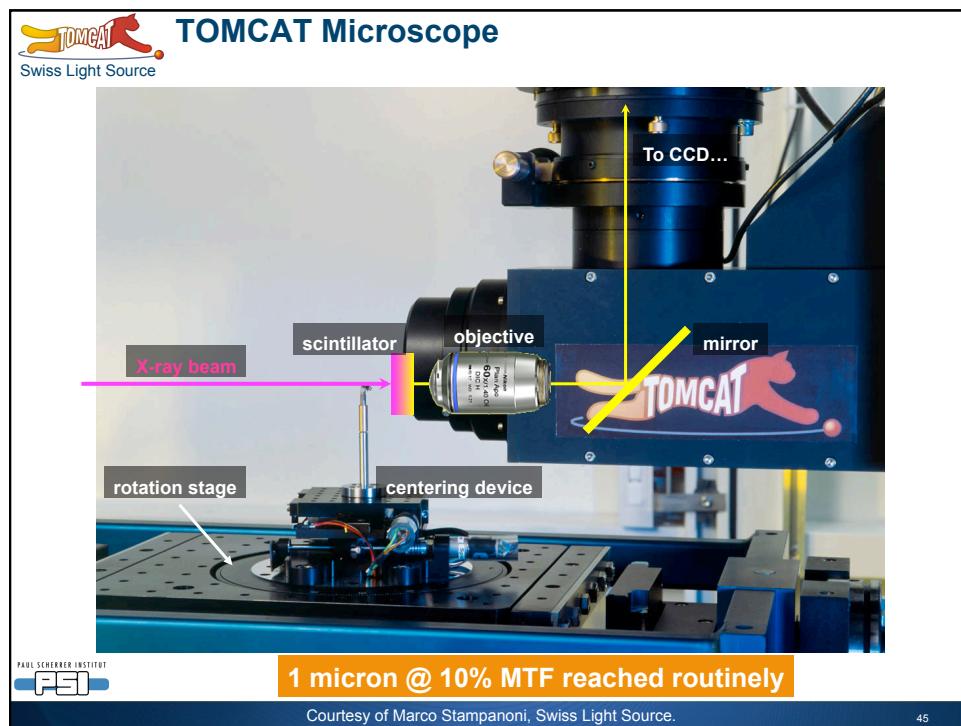










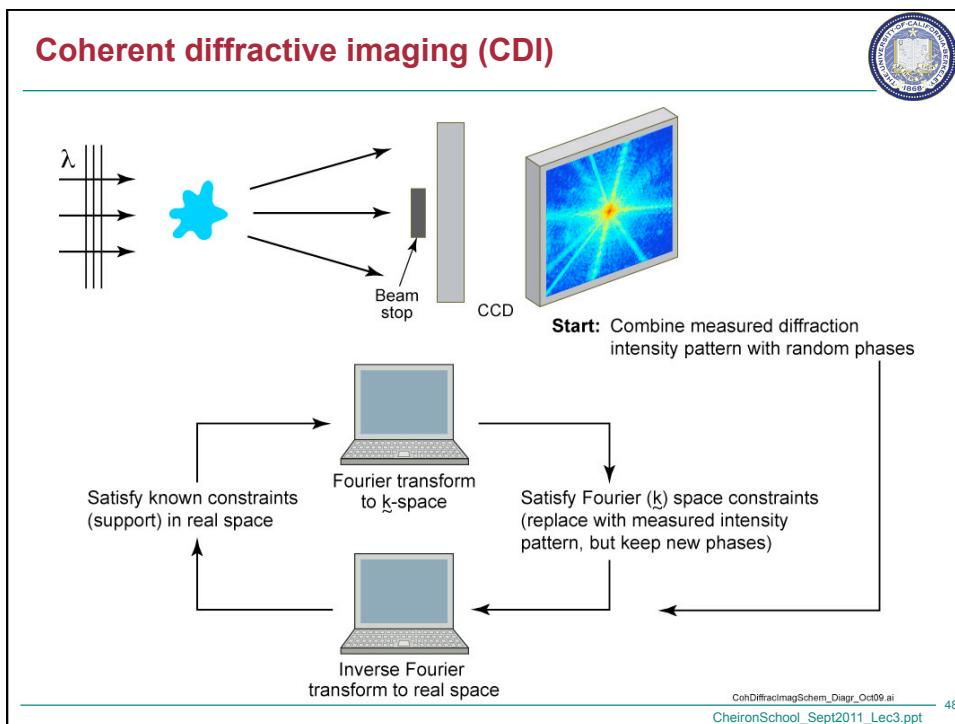


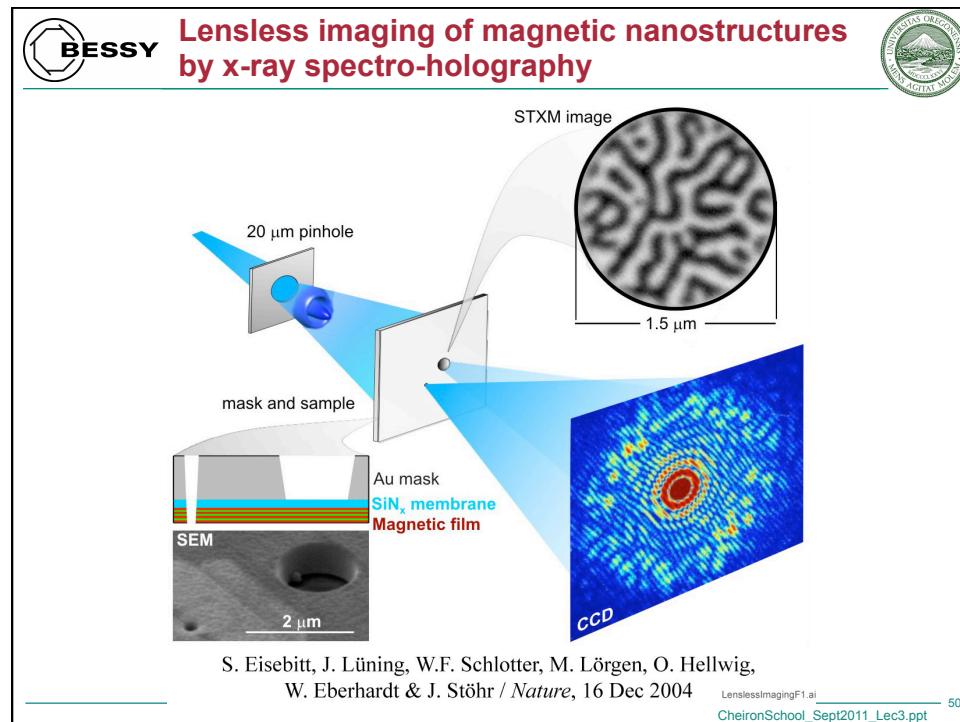
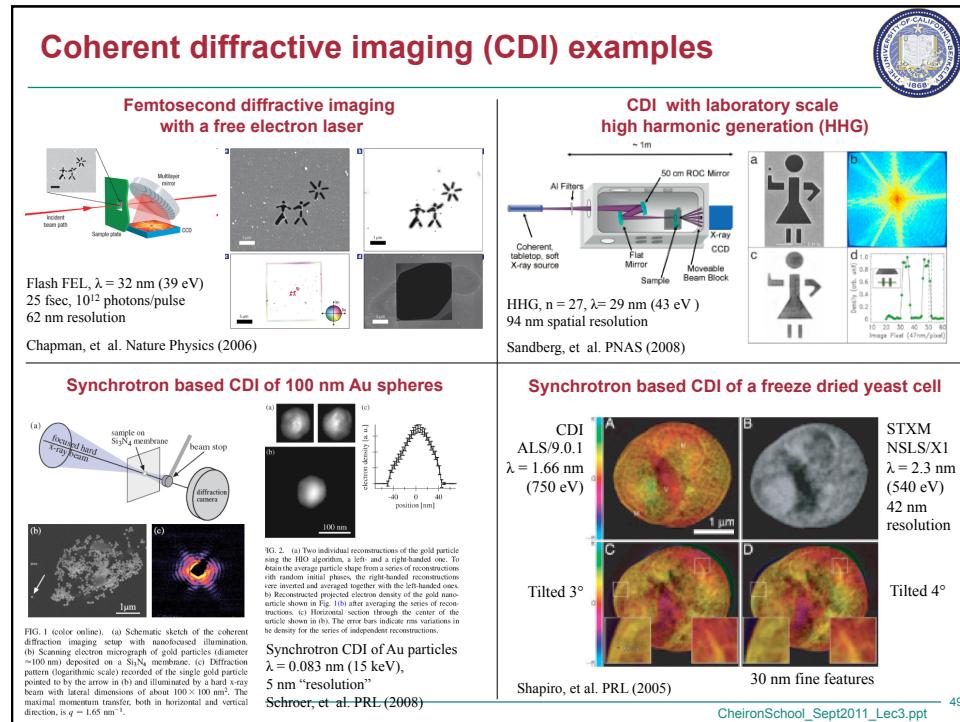
A lens is not necessarily required

$$\Delta r_{\text{resol.}} = k_1 \lambda / \text{NA}$$

“Lensless” coherent diffractive imaging (CDI) is being aggressively pursued.

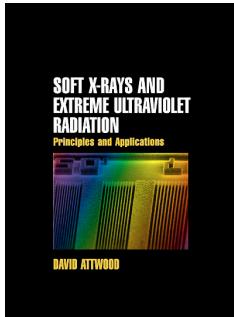
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Lectures online at www.youtube.com



A black book cover with white text. The title is 'SOFT X-RAYS AND EXTREME ULTRAVIOLET RADIATION'. Below it is 'Principles and Applications'. At the bottom is the name 'DAVID ATTWOOD'. To the right of the book is a photograph of the Campanile (Sather Tower) at UC Berkeley.

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